

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Ricky Amos

Group Art Unit: 2815

Serial No.: 09/ 995,031

Examiner: Matthew Landau

Filed: Nov. 29, 2000

In Response to Office Action
Dated: June 7, 2002

For: High Temperature Processing Compatible Metal Gate
Electrode for PFETs and Method for Fabrication

Attorney Docket No.: 64,610-062

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

Date: 6/25/02

Kathy Dixon

RECEIVED

JUL - 8 2002

TECHNOLOGY CENTER 2800

RESPONSE TO OFFICE ACTION

Assistant Commissioner
for Patents
Washington, D.C. 20231

Dear Sir:

In response to an Office Action mailed June 7, 2002 of a restriction requirement imposed by the Examiner, the Applicants hereby elect with traverse the prosecution of Group I, device claims (claims 1-16).

Respectfully submitted,

Tung & Associates

Randy W. Tung
Reg. No. 31,311
Telephone: (248) 540-4040